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FEB 13 2006

## PATENT

Reply under 37 CFR § 1.116  
Expedited Procedure  
Group Art Unit 2822IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicants: MUN, Young Hee et al.

Serial No.: 10/699,438

Filed: October 31, 2003

Title: SILICON WAFER AND  
METHOD OF FABRICATING  
THE SAME

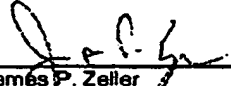
Group Art Unit: 2822

Examiner: GUERRERO, Maria F.

Attorney Docket No.: 29936/39510

I hereby certify that this correspondence is  
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February 13, 2006

  
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## AMENDMENT "B" AFTER FINAL REJECTION

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the final official action dated December 14, 2005, please amend the  
above-identified patent application as set forth herein.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.

Entered  
w/ RCE  
3.16.06JNL  
3.24.06